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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1752
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of
Toshiyuki OGATA, et al.
Appln. No.: 09/922,723
Confirmation No.: 1261
Filed: August 07, 2001
Docket No: Q65755
Group Art Unit: 1752
Examiner: Sin J. Lee
For: POSITIVE RESIST COMPOSITION AND BASE MATERIAL CARRYING LAYER OF
THE POSITIVE RESIST COMPOSITION

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 8, 2004, please amend the above-identified application as follows on the accompanying pages.

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